Notice of References Cited

Applicant/Patent
PRATER et al.

Application/Control No.

08/871,029

Examiner

Daniel Larkin

Art Unit 2856

Page 1 of 1

U.S. PATENT DOCUMENTS

	Document Number Country Code-Number-Kind Code	ocument Number y Code-Number-Kind Code MM-YYYY¹ Name		Classification ²	
Α	5,172,002	12/1992	Marshall	250	306
В					
С					
D					
E					
F		-			
G					
н					
1					
J					
K					
L					
М					

FOREIGN PATENT DOCUMENTS

	Document Number Country Code-Number-Kind Code	Date MM-YYYY ¹	Country	Name	Classification ²	
N						
0				•		
Р						
a						
R						
s						
 т						

NON-PATENT DOCUMENTS

	Include, as applicable: Author, Title, Date, Publisher, Edition or Volume, Pertinent Pages
U	Jung et al., "Novel Stationary-Sample Atomic Force Microscope With Beam-Tracking Lens", Electronic Letters, 04 February 1993, Vol. 29, No. 3, pp. 264-266.
v	
w	
x	

² Classifications may be U.S. or foreign.

 $^{^{\}rm s}$ A copy of this reference is not being furnished with this Office action. See MPEP § 707.05(a).

¹ Dates in MM-YYYY format are publication dates.